

---

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

(Case No. 113.002.D1)

In the Application of: <b>YE ET AL.</b>	)	Group Art Unit:
	)	
Serial No: <b>DIVISIONAL OF 10/390,806</b>	)	Examiner:
	)	
Filed: <b>AUGUST 22, 2003</b>	)	
	)	
Title: <b>SYSTEM AND METHOD FOR LITHOGRAPHY</b>	)	
<b>PROCESS MONITORING AND CONTROL</b>	)	

---

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Preliminary to the examination of the above-referenced application, kindly amend the application as follows: